Hitachi High-Tech HITACHI

Hitachi Tabletop Microscope

Tabletop Microscope The TM3000 is the advanced next-generation tabletop electron microscope from Hitachi.

Perfectly suited to applications in R&D, quality control and education.



The TM3000 builds on the phenomenal global success of its predecessor, with over 1000 instruments installed. Now more advanced microscopy needs are addressed whilst maintaining incredible ease of use - pushing back the boundaries for the tabletop electron microscopy.

[Key Features]

- Compact and portable (24% smaller footprint and 25% lighter)*.
- Simple operation with extensive auto functions.
- Wide magnification range of 15x to 30,000x ensuring you get maximum benefit from the resolution and depth-of-field advantages of electron microscopy.
- Image insulating materials with ease no need for specimen coating with the TM3000's charge-up reduction mode.

Multiple beam conditions and versatile detector control to ensure you get the perfect image.

* Comparison with TM-1000 / Excluding PC and Diaphragm Pump



Compact and portable, with incredibly simple operation

Tabletop installation

The space saving and lightweight design of TM3000 means it can be conveniently installed on a table*. No cooling water is needed, so installation is quick and easy and requires only a standard 100-240 V AC power supply.

(*) requires a table capable of supporting 100 kg.



* Typical configuration of TM3000 with PC.
* Screen shows simulated image.

Environmentally-friendly pumping system



The TM3000 features a dry (oil-free) vacuum system, consisting of a diaphragm pump for rough evacuation and a high performance turbo-molecular pump for main pumping.

• Large specimen handling

The large specimen stage allows mounting of a specimen up to 70 mm diameter and 50 mm thick. X/Y specimen motion: ± 17.5 mm



• Fast specimen exchange

The high-performance vacuum system provides fast pumpdown, but specimen exchange also requires chamber venting. It takes just 1 minute to vent the TM3000 specimen chamber, twice as fast as the TM-1000.

Comparison of chamber venting time



Topographic imaging with a large depth of focus

Complex specimen structures are easily observed with a resolution and depth of focus far beyond what is achievable by optical microscopy.

Focused point



Optical microscope image

Specimen: Movement of wristwatch



Tabletop Microscope TM3000

With a width of just 330mm, laptop-PC based operation and no special installation requirements the TM3000 can be installed almost anywhere. Comprehensive auto-functions ensure it can also be used by anyone.

• Comprehensive auto-functions, with one-click "Start".

Imaging with the TM3000 couldn't be simpler. Pressing the "Start" button automatically turns the beam on, adjusts focus, brightness and contrast and displays the image at an easy-to-view starting magnification of 100x.







Smooth magnification adjustment

Since magnification is increased simply by narrowing the scanned area, continuous magnification adjustment from x15 to x30,000 is achieved by simply dragging the mouse - making it quick and easy to find the area of interest.

Preset magnification

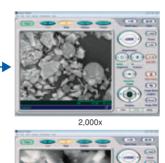
Frequently used magnifications can be saved in memory (preset). The magnification can be changed to a preset value with a click of the mouse.

500x

-



Specimen: Cloth





10,000x Specimen: Foundatio

* Typical configuration of TM3000 with PC.
* Screen shows simulated image.

Motorized stage version

With the optional* motorized specimen stage, all functions of the TM3000 can be operated using the mouse alone. Sample navigation can be performed through the user interface - either by double-clicking a desired destination on the image or by clicking the stage move arrows.

* Please specify manual or motor-drive stage when ordering the TM3000





Versatility is assured – with a wide magnification range and multiple operating conditions.

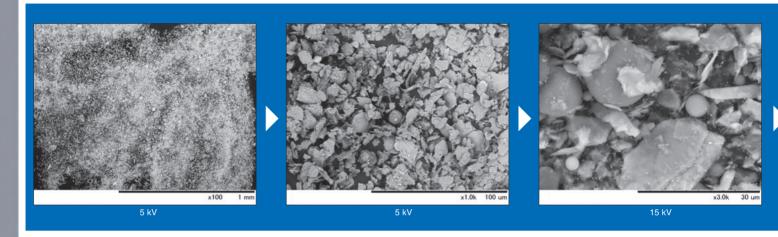
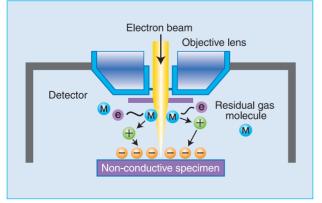


Image non-conducting specimens with ease.

When an electrically non-conducting specimen is observed with a high-vacuum SEM, electrons accumulate on the specimen surface causing a charge-up phenomenon, which prevents normal imaging. Conventionally, to avoid this problem, the sample is usually vacuum coated with a thin layer of metal before observation. This process is not only time consuming, but the metal coating can interfere with imaging and EDX analysis. The TM3000 overcomes this problem with the "charge-up reduction mode" – using low-vacuum operation to eliminate the charge-up effect.

Low-vacuum microscopy

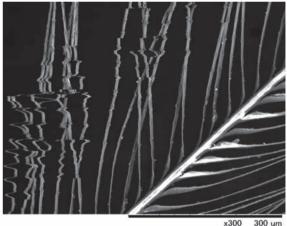
By utilizing a low vacuum level inside the specimen chamber, more gas molecules are present. These gas molecules \bigcirc can collide with the electron beam to generate positive ions \oplus and electrons \bigcirc . Each positive ion \oplus can be neutralized by one of the excess electrons \bigcirc on the specimen surface. In this way the excess electrons on the surface of the sample are removed and the charge-up effect is eliminated or reduced.



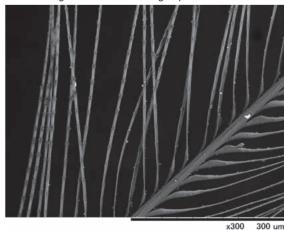
Charge-up reduction mode

The TM3000 can operate either in "standard mode" or "charge-up reduction mode" depending on the extent of the specimen charging.

With image artifact due to charge-up



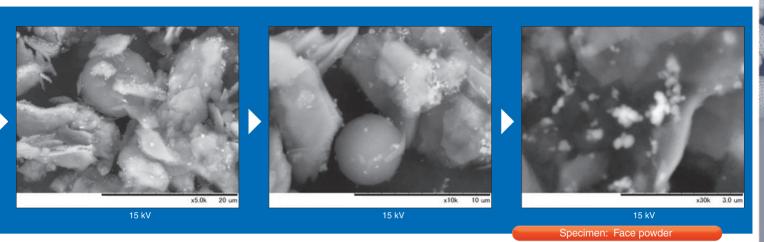
Without image artifact due to charge-up



Specimen: Bird's feather

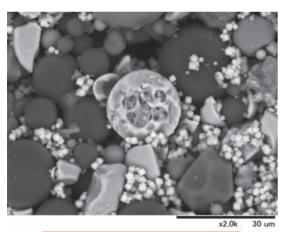
The versatile TM3000 can be used for almost any type of specimen.

Even non-conducting specimens or samples containing moisture can be imaged directly, throughout the whole magnification range of x15 to x30,000, without any special sample preparation.

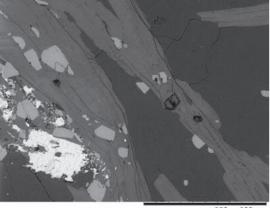


Compositional imaging

In addition to traditional topographic imaging, the TM3000 can produce compositional images, where the different brightness levels represent different composition in the sample. In this mode, higher brightness corresponds to higher atomic number.



Specimen: Powder spray



x250 300 um

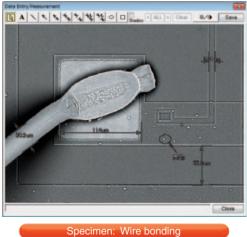
Specimen: Garnet - muscovite - albite schist Specimen courtesy of: Nagoya University Museum Designated Prof. Mamoru Adachi

• Tools for measurement and annotation

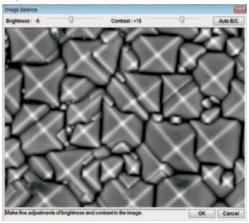
- Distance measurement Distance can be quickly and easily measured by dragging the mouse between two points of interest.
- Graphics/comment input

Simple graphics and comments can be added to the image.

Simple length measurement and graphics/comment input



Brightness/contrast adjustment window



Specimen: Solar battery

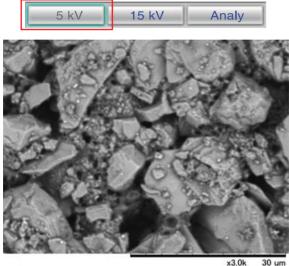
Three independent observation condition modes

The TM3000 features three beam conditions to choose from depending on the information required in the image. The '5 kV', '15 kV' and 'Analysis' modes greatly simplify operating condition setup, and no adjustment is required when switching between modes.

5 kV emphasizes surface detail

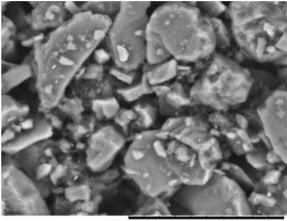
15 kV can be used throughout the magnification range and gives the best resolution

Analysisused for elemental analysis or low contrast specimens

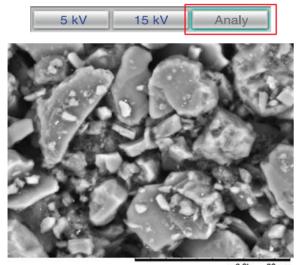


5 kV charge-up reduction mode





x3.0k 30 um 15 kV charge-up reduction mode



x3.0k 30 um Analy (15 kV) charge-up reduction mode

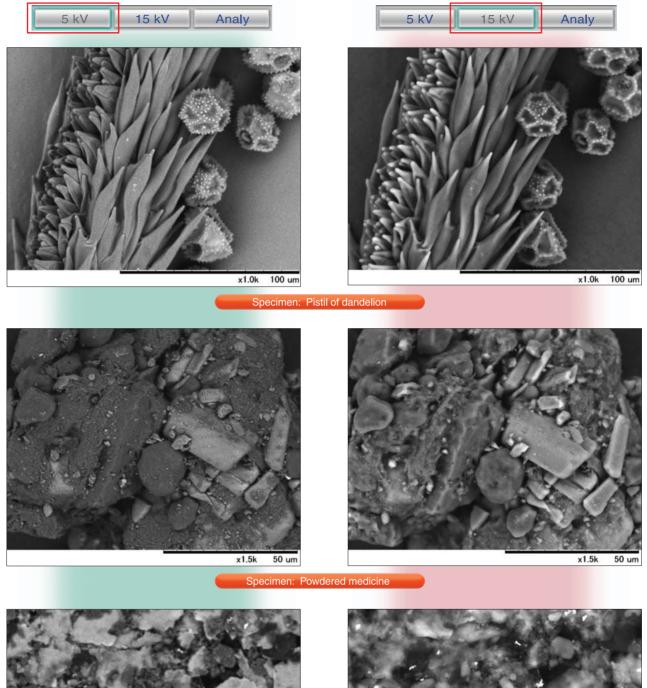
Accelerating voltages

By providing different accelerating voltages in '5 kV' and '15 kV' modes, and using the high sensitivity backscattered electron detector, different types of imaging are possible with the TM3000. An accelerating voltage of 15 kV is used for most imaging applications and offers the best resolution. At 5 kV, the electron beam does not penetrate so far into the sample, so the images show more surface detail.

Accelerating voltage	15 kV	5 kV
Resolution	Best 🗲	
Image information	Subsurface 🗲	> Surface
Backscattered electron signal	High 🗲	

Specimen: Tooth paste

■ Difference in image appearance using different observation condition modes



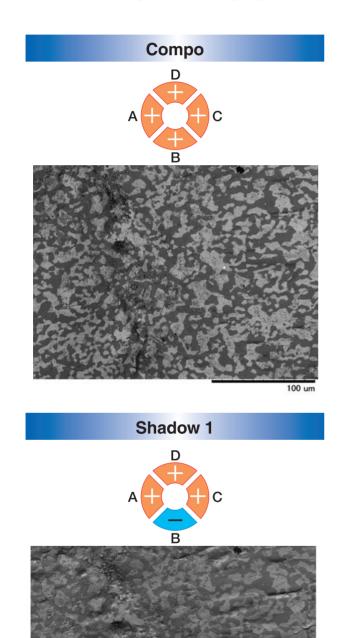
x3.0k 30 um

x3.0k 30 um

Specimen: Adhesive tape

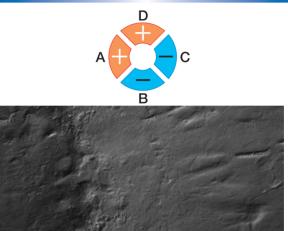
Directional imaging using the 4-segment detector

The TM3000 features a backscattered electron detector with 4 independent segments. By adding or subtracting the signals from the segments in different combinations it is possible to emphasize compositional or topographic detail in the image, as well as produce 'shadowed' images which highlight the sample from a particular direction.

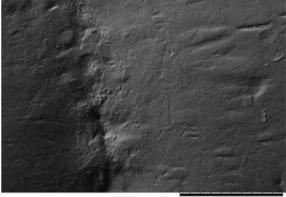


×600

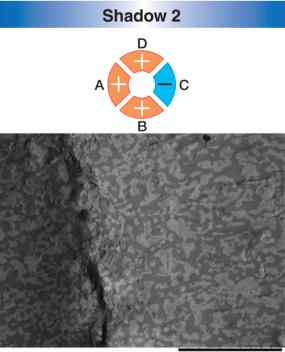
100 un



Торо



x600 100 um



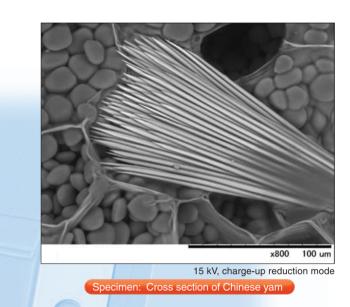
x600 100 um

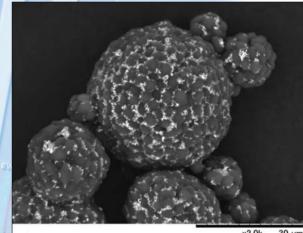
Specimen: Solder

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Application Gallery

■ Food and Medicine

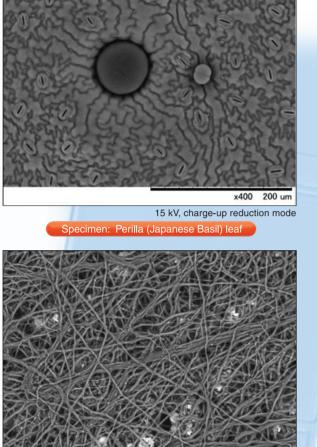




x2.0k 30 um 15 kV, charge-up reduction mode

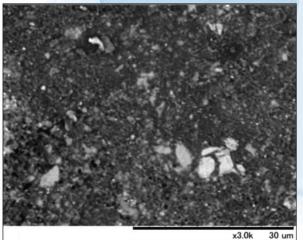


×1.5k 50 um 15 kV, charge-up reduction mode Specimen: Headache remedy tablet



x500 200 um

15 kV, charge-up reduction mode Specimen: Egg shell membrane

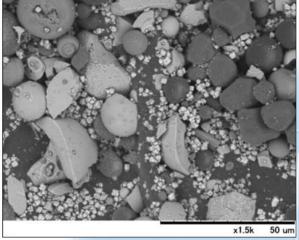


5 kV, charge-up reduction mode Specimen: Pellet surface

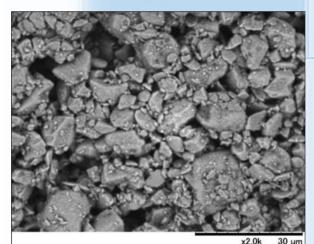
croscope TM3000

Application Gallery

Processed materials

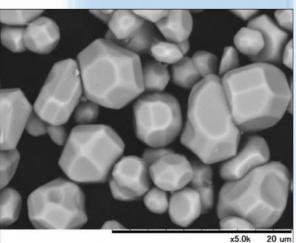


5 kV, charge-up reduction mode Specimen: Powder spray



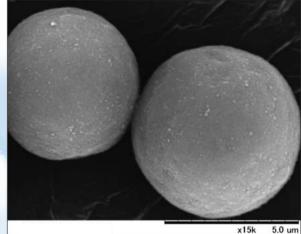
5 kV, charge-up reduction mode

Specimen: Coated paper

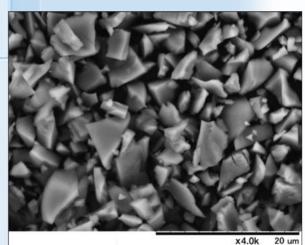


15 kV, charge-up reduction mode

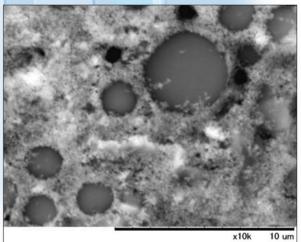
Specimen: Fluorescent material



15 kV, standard mode Specimen: Toner (Pt coated)



15 kV, standard mode Specimen: Alumina particle

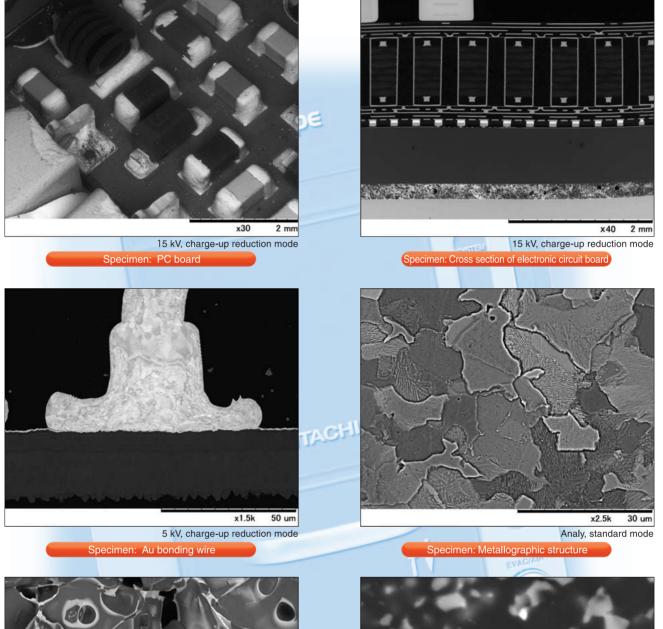


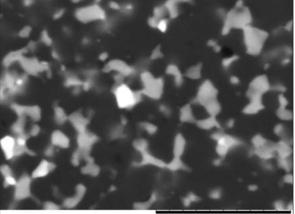
15 kV, charge-up reduction mode

Specimen: Sunscreen lotion

-0

Electronic and metallic materials





x15k 5.0 um 15 kV, charge-up reduction mode Specimen: AITIC circuit board

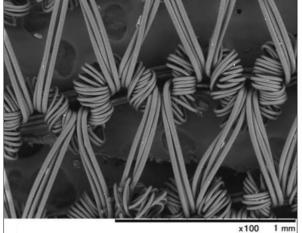
x1.5k 50 um

Analy, charge-up reduction mode

Specimen: Varistor

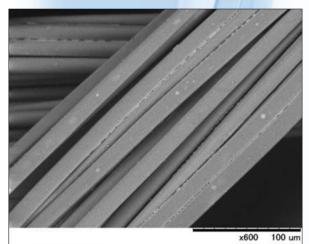
Application Gallery

Textiles



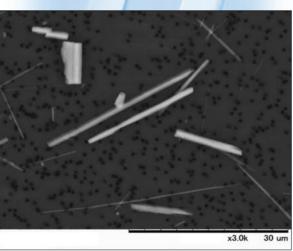
15 kV, charge-up reduction mode

Specimen: Nylon stocking



5 kV, charge-up reduction mode

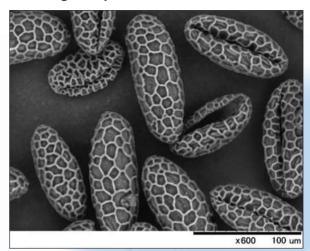
Specimen: Photocatalyst fiber



Specimen: Asbestos

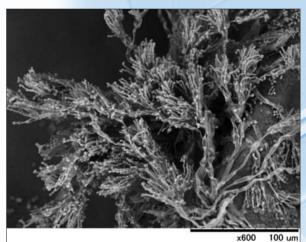
15 kV, standard mode

Biological specimen



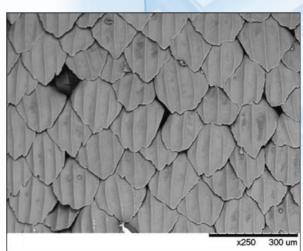
15 kV, charge-up reduction mode

Specimen: Lily pollen



15 kV, charge-up reduction mode

Specimen: Mould spore

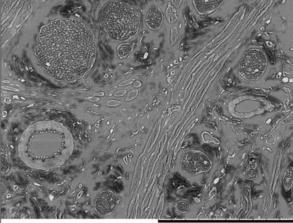


15 kV, standard mode

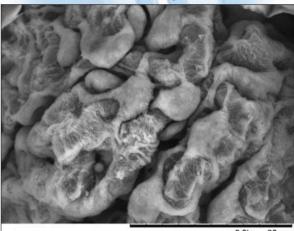
Specimen: Shark skin

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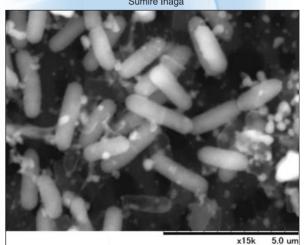


x250 300 um Analy, charge-up reduction mode Specimen: Tongue of rat (deparaffinated section) Specimen courtesy of: Tottori University, Faculty Medicine Sumire Inaga

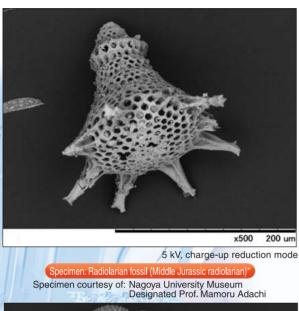


x3.0k 30 um 15 kV, charge-up reduction mode

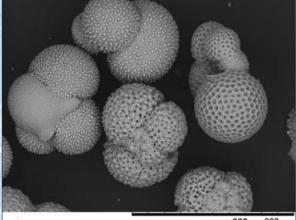
Specimen: Renal glomerulus of rat Specimen courtesy of: Tottori University, Faculty Medicine Sumire Inaga



15 kV, charge-up reduction mode Specimen: Fermented soybean bacteria

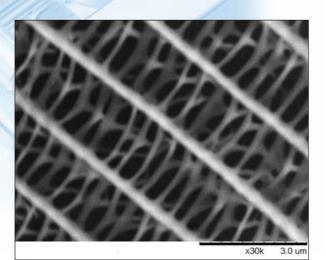


TAC



x300 300 um 15 kV, charge-up reduction mode

Specimen: Planktonic foraminifer



15 kV, charge-up reduction mode

Specimen: Butterfly wing

* Specimen: Middle Jurassic radiolarian fossils from the manganese-carbonate nodule collected in Unuma, Kakamigahara City, Gifu Prefecture Nagoya University Museum (JMP380) (Shinjiro Mizutani, Prof. Emeritus of Nagoya University)

Elemental Analysis made easy (option)

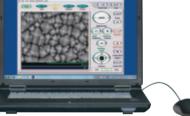
EDX* for the TM3000 is available using 2 different systems. Each system is equipped with the latest SDD (silicon drift detector). The detectors are compact and designed to be housed within the main TM3000 unit. Liquid nitrogen is not required, as with all modern EDX systems.

SuiftEDRO



• Swift multi-point analysis by POINT&ID

● Detectable elements: B5 to U92



Typical configuration of TM3000 with PC.

*Detector built-in type *Screen shows simulated image.

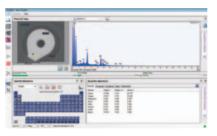
option

SwiftED3000 operation window



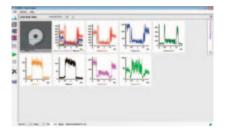
• Element mapping

The distribution for each element present can be displayed. In addition, 3 elements can be displayed simultaneously, in RGB, overlaid upon the BSE image.



Point & ID

POINT&ID enables the user to specify multiple points or areas and acquire spectra sequentially.

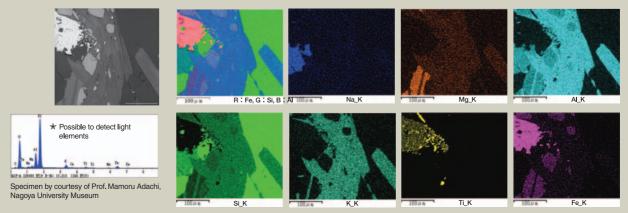


Line scan

For a user-defined line, the intensity profile of each element selected can be displayed.

Example measurement with SwiftED3000

• Analysis of ground thin-section rock specimen (non-coated)



Continuing the "Simple Operation" design concept of the TM3000, all users can take full advantage of the powerful analytical capability including point analysis, area analysis and element mapping.

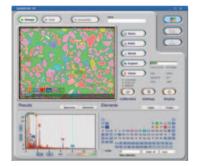
* EDX: Energy Dispersive X-ray Spectrometer



Typical configuration of TM3000 with PC.

*Detector built-in type *Screen shows simulated image.

Quantax70 operation window



Element mapping

The elemental distributions are displayed and overlaid on the BSE image. The intensity and colour of each element can be adjusted to maximize and highlight the data acquired.



Point/Area analysis

The spectrum at any point or area can be displayed by expanding or contracting a "selective area" target. Spectrums can be displayed after measurement by use of smart map.



Line scan

The intensity profile of each element is overlaid on a microscope image of the specific target area.

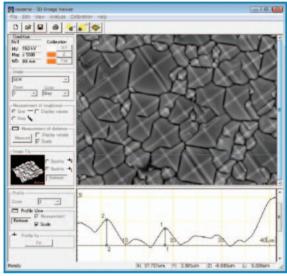
Example measurement with Quantax70

Ni K Cu_K Miniscope image 18 N 18 Sn L Synthesized map Ag L

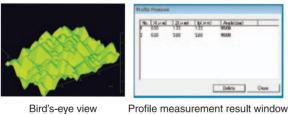
Analysis of electronic component sample embedded in resin (non-coated)

3-dimensional image display /measurement function

- A 3-dimensional model can be generated without sample tilting and alignment, using 4 directional surface profiles from the signals acquired with each segment of the 4-segment backscattered electron detector.
- Surface roughness can be measured easily based on the height measurement between 2 points, the surface area and cross-sectional profile.
- The 3-dimensional model under observation can be manipulated (rotated and zoomed), while rotational manipulation of the model can be recorded in a dynamic image file (AVI format).

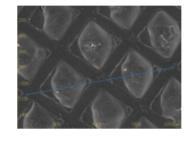


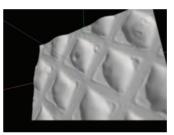
Main window of 3D-Image Viewer



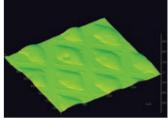
3D-Image viewer function

Specimen: Solar cell



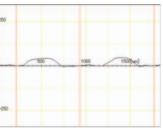


3-dimensional model display



option

Bird's-eye view



Profile measurement result window

Specimen: Food packaging material (Pt-coated)



Items Description Import function Automatic select and read function of four elements image data (Equipped with automatic SEM condition acquisition function) Depth accuracy ± 20% (Reference) Measurement performance is different depending on calibration accuracy, the condition of Measurement the kind of the specimen, the observation mode, and the observation condition. Detectable angle range: ±50 (Reference) (Observation condition: Standard mode) Unavailable in the combination of performance "Charge-up reduction mode" and "5kV mode". Section profile display / Calibration function (X/Y, Z and Flat) / Distance of X and Y, length and angle measurement between two Measurement points specified on the image / Surface area measurement / Distance of X and Y, length and angle measurement between two function points specified on section profile / Surface roughness measurement on section profile / Depth direction zoom-in function in section profile display / Base line correction function (straight line and curved line) / Bird's-eye view display / Color contour line display Three-dimensional display function Rotation and zoom-in / Animation record function of observation screen (AVI file) Windows® VISTA Home Premium (SP1) (32-bit) / Windows® 7 Professional (32-bit) PC OS 3D-Image capture function

3D-VIEW main specifications

Items	Description	
Capture function	Automatic image data acquisition by four elements of quad BSE detector	
Capture pixel count	640×480 pixels (Quick Save), 1,280 \times 960 pixels (Save)	
Brightness adjustment	Automatic	

*A steep topographical surface that exceed detectable angle might not be displayed accurately.

*Windows® is a registered trademark of Microsoft Corporation in the United States and/or other countries.

SwiftED3000 specification

*Manufactured for Hitachi High-Technologies Corporation by Oxford Instruments Analytical Ltd.

Detector

Items	Description
Detector type	Silicon Drift Detector (SDD)
Detection area	30mm ²
Energy resolution	161eV (Cu-K α) (equivalent to 137eV with Mn-K α)
X-ray window	SATW (Super Atmosphere Thin Window)
Detection element	B5 – U92
Thermal cycle	Detector cool down on demand.
Cooling method	2-stage thermoelectric (peltier) cooling (without fan and LN₂ free)

X-stream, mics

Items	Description
Pulse processor	Digital
Multi-channel analyzer	2,048 channel (10eV/ch)

Software

Items	Description
Spectrum display	Expand and contract scale in vertical and horizontal, KLM marker display
Qualitative analysis	Auto ID and manual peak ID
Quantitative analysis	Standardless quantitative analysis, normalize to 100%
Image capture	1,024 × 768, 512 × 384, 256 × 192 pixel
Point & ID (Beam control)	Selectable points: 128 points Recrangle: Arbitrary size settable
Element mapping	Resolution: Select from 128, 256, 512 pixel Max. measureable elements: 32 Mix map: 3 elements
Line scan	Spectrum comparison: two spectra
Help function	On-line
Data management	Managed by project
Spectrum exporting	BMP, TIFF, JPEG, EMSA, Text
Data reporting	Print report template Export to Microsoft [®] Word

Dimensions and weight

Items	Description (Width × Depth × Height, Weight)
Detector unit	145 × 150 × 200mm, 2.7kg
Analyzer unit	290 × 265 × 332mm, 9.3kg

Installation condition

Items	Description
Power	Single-phase AC100~240V (±10%)
(SwiftED3000)	50/60Hz 100VA, 3P cable

Quantax70 specification

*Manufactured for Hitachi High-Technologies Corporation by Bruker Nano GmbH

Detector

Items	Description
Detector type	Silicon drift detector (SDD)
Detection area	30mm ²
Energy resolution	154eV (CuK α) (equivalent to 137eV with Mn-K α)
X-ray window	For light element detection
Detection element	B5~Am95
Thermal cycle	Detector cool down on demand.
Cooling method	2 stage Peltier cooling (No fan, No liquid nitrogen needed) Cooling temperature about -25°C Cooling is not needed when not in use. No detector warm-up needed during venting or sample changing. After power supply is turned on and cooling starts, it can be used in two minutes.

■ MIN SVE signal processing unit

Items	Description
Signal processor	Up to 60,000cps output count rate
Multi-channel analyzer	4,096 chennels (5eV/ch)

External scan box

Items	Description
Interface to TM3000 notebook	USB 2.0 or Ethernet
Interface to microscope	via DBC cable

Software

Items	Description
Spectrum display	Scale expansion in vertical and horizontal direction, Automatic scaling, KLM marker display
Qualitative analysis	Automatic ID and manual peak ID
Quantitative analysis	Standardless quantitative analysis, normalize to 100%
Image capture	1,024 × 768, 640 × 480, 320 × 240 pixel
Element mapping	1,024 × 768, 640 × 480, 320 × 240 pixel Displays as single element map Display of several maps as overlaid image Overlay of single and mixed element map with BSE image Color of each map can be changed
Line scan	Flexible line positioning in all directions Individual selection of line colors for each element Overlay of line scan profile with scan image Display of line scan spectrum
Spot/area analysis	Spot can be positioned anywhere on the image Single circle but can be moved and resized (10-768pixels). Analysis results of spot: Display of spectrum, results table and graphic display Automatic element ID of spot Automatic quantification of spot Manual selection/deselection of elements
Data reporting	Report template for printing Export of spectra to BMP, TIFF, JPEG, Excel 2007 and Text Export of spectra and results to Microsoft [®] Word 2007

Dimensions and weight

Items	Description (Width × Depth × Height, Weight)
Detector (housed within TM3000)	145 × 130 × 105mm, 1.5kg
MIN SVE signal processing unit	228 × 116 × 66mm, 1.0kg
External scan box	$228 \times 116 \times 66$ mm, 1.0kg

Installation conditions

Items	Description
Power (Quantax70)	MIN SVE signal Single-phase AC100~240V (±10%)
	processing unit 50/60Hz 25VA, 3P cable
	External scan box Single-phase AC100~240V (±10%)
	50/60Hz 15VA, 3P cable

TM3000 specification

Specifications

Description
15 to 30,000× (digital zoom: 2×, 4×)
5kV/15kV/Analysis
Standard mode Charge-up reduction mode
COMPO/Shadow 1/Shadow 2/TOPO
X: ±17.5mm, Y: ±17.5mm
70mm in diameter
50mm
Pre-centered cartridge filament
High-Sensitivity semiconductor BSE detector
Auto start, Auto focus,
Auto brightness/contrast
Raster rotation, Magnification preset (two steps) Image shift (±50µm@D*=4.5)
640 × 480 pixels, 1,280 × 960 pixels
HDD of PC and other removal media
BMP, TIFF, JPEG
Micron marker, micron value, date and time,
image number and comments, Image mode,
Observation condition, D* (Distance), Observation mode
Turbomolecular pump: $30\ell/s \times 1$ unit,
Diaphragm pump: 1m ³ /h × 1 unit
Over-current protection function, built-in ELCB

*D (Distance) is defined as the distance between lower surface of a high-sensitive semiconductor BSE detector and sample surface.

Required PC specifications

Items	Description
OS	Windows® 7
CPU	Intel [®] Core [™] 2 Duo P8700 or compatible CPU
Memory size	2GB or larger
Display monitor	15.4 type, WXGA 1,280 × 800 pixels
Interface connector	USB 2.0

*An associated PC to be procured locally.

*Windows is a registered trademark of Microsoft Corporation in the United States and/or other countries. *Intel is a registered trademark of Intel Corp. or its affiliated companies in the United States and/or other countries. *Specifications of a PC are subject to change.

Dimensions and weight

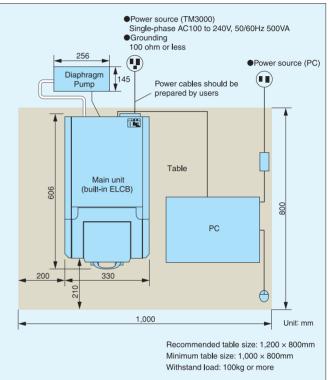
Items	Description (Width × Depth × Height, Weight)
Main unit	$330 \times 606 \times 565$ mm, 63.0kg (manual stage) $330 \times 630 \times 565$ mm, 66.0kg (motor drive stage)
Diaphragm pump	145 × 256 × 217mm, 4.5kg

Installation condition

Description
15 to 30°C (Δt=±2.5°C/h or less)
70%RH or less
Single-phase AC100 to 240V (Minimum: 90 [V], Maximum: 250 [V])
100 ohm or less

*Another power source for PC is required.

Minimum installation layout



*A table with casters is not suitable to put a main unit of TM3000 on.

*Recommended table size: 1,200 × 800mm, withstand load: 100kg or more.

*Periodical maintenance is required for this apparatus.

*Limited to indoor operation.

Notice: For correct operation, follow the instruction manual when using the instrument.

Specifications in this catalog are subject to change with or without notice, as Hitachi High-Technologies Corporation continues to develop the latest technologies and products for our customers.

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Tokyo, Japan http://www.hitachi-hitec.com/global/em/

24-14, Nishi-shimbashi,1-chome, Minato-ku Tokyo,105-8717, Japan

For technical consultation before purchase, please contact:contact@nst.hitachi-hitec.com